

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Takashi FUJII et al.

Serial No.: 10/784,211

Filed: February 24, 2004

For: PROCESS FOR PRODUCING COLD

FIELD-EMISSION CATHODES

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with 37 C.F.R. § 1.97 and § 1.98, Applicants bring the disclosures attached and listed on completed Form PTO-1449 to the Examiner's attention and request that they be considered and made of record in this application.

Prompt examination on the merits is respectfully requested.

Respectfully submitted,

Garrett V. Davis Reg. No. 32,023

Roylance, Abrams, Berdo & Goodman, L.L.P. 1300 19th Street, N.W., Suite 600 Washington, D.C. 20036-1649 (202) 659-9076

Dated: *May 20, 2004*

Substitute for form 1449A/PTO

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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| Filing Date | February 24, 2 | 004 |
| First Named Inventor | Takashi FUJII | / |
| Art Unit | | MAY 2 11 200/ |
| Examiner Name | | 2004 |
| Attorney Docket Number | 46379 | E E |
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